Docket No. TRANSMITTAL OF FORMAL DRAWINGS BUR920020094US1 (16895) Douglas D. Coolbaugh, et al, In Re Application Of: AUS 0 5 2004 Group Art Unit Confirmation 100, Examiner Customer No. Application No. Filing Date 10/605,439 9/30/2003 2438 Unassigned 23389 1765 PRECISION POLYSILICON RESISTOR PROCESS Invention: Address to: **Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450 Transmitted herewith are: 4 sheets of formal drawing(s) for this application. X Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c). Dated: August 3, 2004 Signature Leslie S. Szivos, Ph.D.

Registration No. 39,394

certify that this document and attached formal drawings with the U.S. are being deposited on 8/3/2004 Postal Service as first clase mail under \$7 C.F.R. 1.8 and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313

Signature of Person Mailing Correspondence

Leslie S. Szivos, Ph.D.

Typed or Printed Name of Person Mailing Correspondence